Attorney's Docket No.: 042390.P4220

**Patent** 

| IN THE UNITED STATES P.  | ATENT       | AND TRADEMARK OFFICE      | r              | 17/14                |
|--|-------------|---------------------------|----------------|----------------------|
| In Re Application of:  | )           |                           |                | 74.                  |
| Bohr, Mark T.  | )           |                           |                | Pre-                 |
| U.S. Serial No: 09/002,178                                       | )           | Examiner: Guerrero, Maria |                | Mespera              |
| Filed: December 31, 1997   | ý           | Art Unit: 2822            |                | G Story              |
| For: WAFER PASSIVATION<br>STRUCTURE AND METHOD OF<br>FABRICATION | )<br>)<br>) |                           | TC 28          |                      |
| Assistant Commissioner for Patents Washington, D.C. 20231        |             |                           | 2800 MAIL ROOM | RECEIVED SEP 27 2001 |

## PRELIMINARY AMENDMENT

Dear Sir:

Please enter the enclosed Preliminary Amendment and consider the following remarks prior to examination of the above-referenced case.

| FIRST CLASS CERTIFICATE OF M I hereby certify that this correspondence is being deposited with sufficient postage in an envelope addressed to the Assistant Con | the United States Postal Service as first class mail with |
|---|---|
| on September 21, 2001  Date of Deposit  |   |
| Name of Person Mailing Correspondence  Jenusa Edwards  Signature  | September 21, 2001  |

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